

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Shinji MAEKAWA et al.) Group Art Unit: 2812
Application No. 10/575,492) Examiner: Stanetta D. Isaac
Filed: April 12, 2006) Confirmation No. 3788
For: METHOD FOR FORMING WIRING,)
METHOD FOR MANUFACTURING)
THIN FILM TRANSISTOR AND)
DROPLET DISCHARGE METHOD) Date: April 7, 2008

AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed January 8, 2008, please amend the above identified application as follows: